

AMENDMENT TRANSMITTAL LETTER

Docket Number
APM-01102

Application Number
09/854,614

Filing Date
May 14, 2001

Examiner
JOLLEY, KIRSTEN

Group Art Unit
1762

Invention Title
APPARATUS FOR SPIN-COATING SEMICONDUCTOR SUBSTRATE AND METHOD OF DOING THE SAME

TO THE ASSISTANT COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application, including:

- (X) Amendment and Response; and
- (X) Return receipt postcard.

CLAIMS AS AMENDED

	(1) CLAIMS REMAINING AFTER AMENDMENT		(2) HIGHEST NUMBER PREVIOUSLY PAID FOR	(3) PRESENT NUMBER EXTRA	RATE	FEE
TOTAL CLAIMS	7	minus	20		x \$18	
INDEPENDENT CLAIMS	1	minus	3		x \$78	
MULTIPLE DEPENDENT CLAIM ADDED					\$260	
					TOTAL	\$
If applicant has small entity status under 37 CFR 1.9 and 1.27, then divide total fee by 2, and enter amount here.				SMALL ENTITY TOTAL		\$

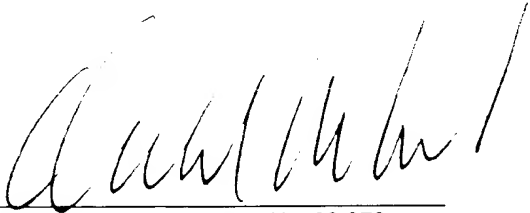
* If the entry in column 1 is less than the entry in column 2, write "0" in column 3.

** If the highest number previously paid for IN THIS SPACE is less than 20, enter "20."

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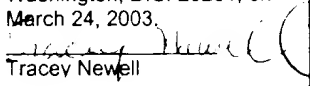
The "highest number previously paid for" (total or independent) is the highest number found in the appropriate box in column 1.

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- () A check in the amount of \$_____ to cover the filing fee is enclosed.
- (X) Please credit any overpayment and/or charge any additional filing fees required under 37 CFR §§ 1.16 and 1.17 to our **Deposit Account Number 031721**.


Donald W. Muirhead, Reg. No. 33,978

March 24, 2003
Date

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on March 24, 2003.


Tracey Newell

MAR 31 2003

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Shuichi FURUOYA

Appl. No.: 09/854,614

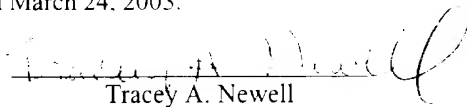
Filed: May 14, 2001

For: APPARATUS FOR SPIN-COATING
SEMICONDUCTOR SUBSTRATE
AND METHOD OF DOING THE SAME

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: Art Unit: 1762
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: Examiner: Jolley, Kirsten
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: Atty Docket: APM-01102
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CERTIFICATE OF MAILING

I hereby certify that the foregoing document is being deposited with the United States Postal Service as first class mail, postage prepaid, "Post Office to Addressee", in an envelope addressed to: Commissioner of Patents, Washington, DC 20231 on March 24, 2003.


Tracey A. Newell

AMENDMENT AND RESPONSE

Commissioner for Patents
Washington, D.C. 20231

Sir:

This paper is being provided in response to the Office Action dated December 30, 2002, for the above-captioned U.S. patent application.

It is not believed that extensions of time or fees for net addition of claims are required, beyond those which may otherwise be provided for in documents accompanying this paper. However, in the event that additional extensions of time are necessary, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required for consideration of this paper (including fees for net addition of claims) are authorized to be charged in two originally-executed copies of an Amendment Transmittal Letter filed herewith. A clean-copy list of the claims as amended herein is attached.